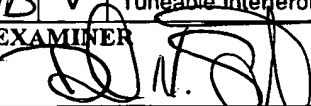


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		Docket Number 074036.0134		Group Art Unit 2873 Filing Date May 19, 2004				
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DIS	B	4,900,119	02/13/90	Hill, et al.	359 350	51 90-45	04/01/88	
DIS	C	5,103,340	04/07/1992	Dono et al.	385	46	08/07/1991	
DIS	D	5,212,743	05/18/93	Heismann	385	11	02/12/92	
DIS	E	5,291,502	03/01/1994	Pezeshki et al.	372	20	09/04/1992	
DIS	F	5,311,360	05/10/94	Bloom, et al.	359	572	04/28/92	
DIS	G	5,343,542	08/30/1994	Kash et al.	385	31	04/22/1993	
DIS	H	5,459,610	10/17/95	Bloom, et al.	359	572	05/20/93	
DIS	I	5,500,761	03/19/96	Goossen, et al.	359	290	01/27/94	
DIS	J	5,654,819	08/05/97	Goossen, et al.	359	291	01/07/95	
DIS	K	5,659,418	08/19/97	Yurke	359	290	02/05/96	
DIS	L	5,661,592	08/26/97	Bornstein, et al.	359	291	01/07/95	
DIS	M	5,701,193	12/23/97	Vogel, et al.	359	290	02/21/96	
DIS	N	5,745,271	04/28/98	Ford, et al.	359	130	07/31/96	
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		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
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DIS	O	0 667 548 A1	16.08.1995	EP	G02B	26/02	X	
DIS	P	0 689 078 A1	27.12.1995	EP	G02B	26/08	X	
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DIS	R	C. Marxer, et al., "Megahertz Opto-Mechanical Modulator," Elsevier Science S.A., pp. 46-50						1996
DIS	S	C. M. Ragdale, et al., "Integrated Three Channel Laser and Optical Multiplexer for Narrowband Wavelength Division Multiplexing," Electronics Letters, Vol. 30, No. 11, pp. 897-898						05/26/94
DIS	T	K. O. Hill, et al., "Narrow-Bandwidth Optical Waveguide Transmission Filters," Electronic Letters, Vol. 23, No. 9, pp. 465-466						04/23/87
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PTO-1449 Information Disclosure Citation in an Application		Application No. <div style="font-size: 1.5em; font-family: cursive;">10/849,346</div>		Applicant(s) Mohammed N. Islam et al.		
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	C	5,825,528	10/20/98	Goossen	359	291	12/26/95
	D	5,835,255	11/10/98	Miles	359	291	05/05/94
	E	5,841,579	11/24/98	Bloom, et al.	359	572	06/07/95
	F	5,850,492	12/15/98	Morasca, et al.	385	11	11/06/96
	G	5,870,221	02/09/99	Goossen	359	290	07/25/97
	H	5,909,303	06/01/1999	Trezza et al.	359	248	01/03/1997
	I	5,914,804	06/22/99	Goossen	359	291	01/28/98
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	K	5,943,155	08/24/99	Goossen	359	247	08/12/98
	L	5,943,158	08/24/99	Ford, et al.	359	295	05/05/98
	M	5,943,454	08/24/99	Aksyuk, et al.	385	22	08/15/97
↓	N	5,949,571	09/07/99	Goossen, et al.	359	291	07/30/98

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	T M.W. Chbat, "High-spectral-efficiency transmission systems," OFC 2000, Baltimore, MD, pp TuJ1-1, 134-136	
	U J.W. Bayless, et al., "The Specification and Design of Bandlimited Digital Radio Systems," IEEE Transactions on Communications, Vol. COM-27 (12): pp. 1763-1770	
↓	V D.E. Sene, et al., "Polysilicon Micromechanical Gratings for Optical Modulation," Elsevier Vol. Sensors and Actuators (A 57), pp. 145-151	

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PTO-1449	Application No.	Applicant(s)	
	10 849 346	Mohammed N. Islam et al.	
Information Disclosure Citation in an Application	Docket Number	Group Art Unit	Filing Date
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	C	5,974,207	10/26/99	Aksyuk, et al.	385	24	12/23/97
	D	5,986,796	11/16/99	Miles	359	260	11/05/96
	E	5,999,319	12/07/1999	Castracane	359	573	04/29/1998
	F	6,002,513	12/14/99	Goossen, et al.	359	291	06/22/98
	G	6,025,950	02/15/2000	Tayebati et al.	359	244	07/27/1998
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	I	6,123,985	09/26/2000	Robinson et al.	427	162	10/28/1998
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	L	6,271,052 B1	08/07/2001	Miller et al.	438	50	10/19/2000
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DIS	N	01/67156 A2	13.09.2001	WO	G02B	26/00	X	
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	Q	01/67171 A2	13.09.2001	WO	G02F	1/21	X	
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DIS	S	D.M. Burns, et al., "Micro-Electro-Mechanical Variable Blaze Gratings," IEEE 10th Annual International Workshop on Micro Mechanical Systems, pp. 385-391	1997
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8/30/2004

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		Docket Number 074036.0134		Group Art Unit <div style="font-size: 1.2em; font-family: cursive;">2873</div>	
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	B	6,373,632 B1	04/16/2002	Flanders	359	578	08/25/2000
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	D	2002/0035193 A1	02/20/2003	Islam et al.	359	290	08/22/2002
	E	2003/0081878 A1	05/01/2003	Joyner et al.	385	14	10/08/2002
	F	2003/0086465 A1	05/08/2003	Peters et al.	372	50	10/30/2002
<div style="font-family: cursive;">✓</div>	G	2003/0095736 A1	05/22/2003	Kish, JR. et al.	385	14	10/08/2002
<div style="font-family: cursive;">DIS</div>	H	2003/0095737 A1	05/22/2003	Welch et al.	385	14	10/08/2002
	I	6,597,492 B2	07/22/2003	Islam et al.	359	291	08/22/2002
<div style="font-family: cursive;">DIS</div>	J	6,611,366 B1	08/26/2003	Islam et al.	359	291	04/22/2002
<div style="font-family: cursive;">DIS</div>	K	6,654,157 B2	11/25/2003	Islam et al.	359	291	08/22/2002

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							YES	NO
<div style="font-family: cursive;">DIS</div>	L	WO 01/37021 A1	14.11.2000	PCT	G02B	6/42	X	
	M	WO 01/79795 A1	22.03.2001	PCT	G01J	3/28	X	
<div style="font-family: cursive;">✓</div>	N	WO 02/056521 A1	02.11.2001	PCT	H04J	14/00	X	

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<div style="font-family: cursive;">DIS</div>	O	SLM "GLV Technology," www.siliconlight.com
	P	R.W. Corrigan, et al., "Grating Light Valve Technology for Projection Displays," Presented at the International Display Workshop, Kobe, Japan
	Q	M. Ming, et al., "Principles and Applications of Optical Communications," Irwin, pp. 468 & 470
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	S	SLM "The Scanned Grating Light Valve Display Architecture," www.siliconlight.com
<div style="font-family: cursive;">✓</div>	T	A. Willner, "WDM Systems 1," OFC '97, Dallas, TX, pp. TuJ, 43-45

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		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
DB	B	WO 02/059655 A2	20.12.2001	PCT	G02B		X
	C	WO 02/06860 A1	11.07.2001	PCT	G02B	5/18	X
↓	D	WO 02/10822 A1	31.07.2001	PCT	G02B	6/34	X
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	H	D.M. Burns, et al., "Development of Michromechnical Variable Blaze Gratings," Elsevier Science S.A., vol. Sensors and Actuators, pp. 7-15					1998
	I	C.K. Madsen, et al., "A Tunable Dispersion Compensating MEMS All-Pass Filter," IEEE Photonics Technology Letters, Vol. 12 (6), pp. 651-653					2000
	J	J.E. Ford, et al., "Passband-Free Dynamic WDM Equalization," ECOC '98, Madrid, Spain, pp. 317-318					1998
	K	K.W. Goossen, et al., "Micromechanical Gain Slope Compensator for Spectrally Linear Optical Power Equalization					2000
	L	K.W. Goossen, et al., "Silicon Modulator Based on Mechanically-Active Anti-Reflection Layer with 1 Mbit/sec Capability for Fiber-in-the-Loop Applications," IEEE Photonics Technology Letters, Vol. 6 (9), pp. 1119-1121					1994
	M	L.Y. Lin, et al., "Angular-Precision Enhancement in Free-Space Micromachined Optical Switches," IEEE Photonics Technology Letters, Vol. 11 (10), pp. 1253-1255					1999
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		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<div style="font-size: 1.5em; font-family: cursive;">OK</div>	B	WO 01/37021 A1	14.11.2000	PCT	G02B	6/42	X
<div style="font-size: 1.5em; font-family: cursive;">↓</div>	C	WO 01/79795 A1	22.03.2001	PCT	G01J	3/28	X
<div style="font-size: 1.5em; font-family: cursive;">↓</div>	D	WO 02/056521 A1	02.11.2001	PCT	H04J	14/00	X
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	F	S.R. Mallinson, "Wavelength-selective filters for single-mode fiber WDM systems using Fabry-Perot Interferometers," Applied Optics, Vol. 26 (3), pp. 430-436					1987
	G	L.Y. Lin, et al., "Micromachined Polarization-state-controller and its Application to Polarization-mode Dispersion-compensation," OFC 2000, Baltimore, MD, pp. ThQ3-1, 144-246					2000
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	I	Author Unknown, "Diffraction and Interference," Optics, Chapter 6, pp. 102-103					Undated
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	N	Sadot et al., "Tunable Optical Filters for Dense WDM Networks," IEEE Communications Magazine, pp. 50-55					12/1998
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							YES	NO
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I	C	WO 02/06860 A1	11.07.2001	PCT	G02B	5/18	X	
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PTO-1449 Information Disclosure Citation in an Application		Application No. <div style="font-size: 1.5em; font-weight: bold;">10/849346</div>		Applicant(s) Mohammed N. Islam et al.	
		Docket Number 074036.0134		Group Art Unit <div style="font-size: 1.5em; font-weight: bold;">2873</div>	
				Filing Date May 19, 2004	

U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A	/					
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						
	L						

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	M	WO 02/21191 A1	07.09.2001	PCT	G02B	27/10	X	
		WO 02/50588 A1	20.12.2001	PCT	G02B	6/26	X	

NON-PATENT DOCUMENTS			
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
	N	Goossen et al., "Integrated mechanical anti-reflection switch (MARS) device for fiber-to-the-home applications," http://mirlynweb.lib.umich.edu/WebZ/FETCH?sessionId=01-35557-462149016&recno=13&re	05/08/2002
	O	"ELASTIC-45 tunable interferometer component," Solus, Preliminary Datasheet and applications	Undated
	P		
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EXAMINER <div style="font-size: 1.5em; font-weight: bold;">DAVID SPECTOR</div>	DATE CONSIDERED <div style="font-size: 1.5em; font-weight: bold;">8/30/2004</div>	
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